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Assistant Commissioner for Patents  
and Trademarks  
Washington, D. C. 20231

JCS49 U.S. PTO  
09/191743  
11/13/98

Transmitted herewith for filing is the patent application of:

**INVENTOR(S):** Raffaele ZAMBRANO

**TITLE:** IN-SITU DEPOSITION AND DOPING PROCESS FOR POLYCRYSTALLINE  
SILICON LAYERS AND THE RESULTING DEVICE

In connection with this application, the following are enclosed:

13 Pages of Specification, Claims and Abstract  
24 Claims  
1 Sheets of Drawing (FIGS. 1-2d)  
XX Declaration, Power of Attorney (unexecuted)  
XX Information Disclosure Statement W1449/7 Refs.

The fee has been calculated as shown below. (Small entity fees indicated in parentheses.)

(1) For	(2) Number Filed	(3) Number Extra	(4) Rate	(5) Basic Fee \$790 (\$395)
Total Claims	24 - 20 =	4	x \$22 (x \$11)	878.00
Independent Claims	4 - 3 =	1	x \$82 (x \$41)	82.00
Multiple Dependent Claims			\$270 (\$135)	0.00
Assignment Recording Fee			\$ 40	0.00
TOTAL FEE:				\$960.00

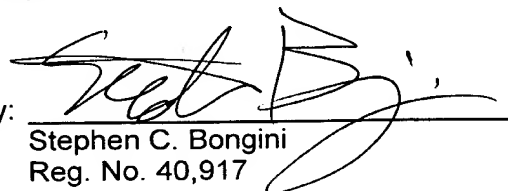
XX A check in the amount of \$960.00 is enclosed.

XX The Commissioner is hereby authorized to charge payments of (1) any additional filing fees required under 37 CFR 1.16, and/or (2) any patent application processing fees under 37 CFR 1.17 associated with this application or credit any overpayment to Deposit Account No. 50-0288. A duplicate copy of this sheet is also enclosed

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Respectfully submitted,

By:   
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